

Atty. Dkt. No. 040256-0135

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shuji HAHAKURA, et al.
Title: METHOD OF PRODUCING
OXIDE SUPERCONDUCTING
FILM
Appl. No.: 10/511,268
International Filing Date: 04/17/2003
371(c) Date: 10/20/2004
Examiner: Unknown
Art Unit: 1751
Confirmation Number: 6578

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.56

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56.

A copy of each non-U.S. patent document and each non-patent document is being submitted to comply with the provisions of 37 CFR §1.97 and §1.98.

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application or that such document is considered material to patentability as defined in 37 CFR §1.56(b). Applicants do not waive any rights to take any action which would be

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appropriate to antedate or otherwise remove as a competent reference any document which is determined to be a *prima facie* art reference against the claims of the present application.

TIMING OF THE DISCLOSURE

The listed documents are being submitted in compliance with 37 CFR §1.97(b), before the mailing date of the first Office Action on the merits.

RELEVANCE OF EACH DOCUMENT

Any document listed on the attached PTO/SB/08 was cited as being relevant during the prosecution of the corresponding European application. A copy of the European Search Report is attached setting forth the portion of each document considered relevant by the examiner.

All of the documents are in English.

Applicants respectfully request that each listed document be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO/SB/08 be returned in accordance with MPEP §609.

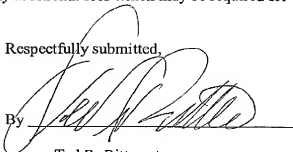
Although Applicant believes that no fee is required for this Request, the Commissioner is hereby authorized to charge any additional fees which may be required for this Request to Deposit Account No. 19-0741.

Respectfully submitted,

Date

July 18, 2007

By



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Substitute for form 1449/PTO
**INFORMATION DISCLOSURE
 STATEMENT BY APPLICANT**

Date Submitted: July 18, 2007

(use as many sheets as necessary)

Sheet 1 of 1

Complete If Known

Application Number 10/511,268
 Filing Date 10/20/2004
 First Named Inventor Shuji HAHAKURA
 Art Unit 1751
 Examiner Name Unknown
 Attorney Docket Number 040256-0135

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/BT/	A1	US-5,206,212	04-27-1993	Okuda	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Foreign Patent Document Country Code* Number* Kind Code ³ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
/BT/	A2	DAM B ET AL.: "The Transition from 2D-nucleation to spiral growth in pulsed laser deposited YBa ₂ Cu ₃ O ₇ -delta films" PHYSICA C, North-Holland Publishing, Amsterdam, NL, vol. 305, no. 1-2, September 1998 (1998-09), pages 1-10, XP004142507, ISSN: 0921-4534	
/BT/	A3	NORTON M.G. ET AL.: "On the Optimization Of The Laser Ablation Process For The Deposition Of YBa ₂ Cu ₃ O ₇ -Thin Films" PHYSICA C, North-Holland Publishing, Amsterdam, NL, vol. 172, no. 1/2, December 1, 1990 (1990-12-01), pages 47-56, XP000243732, ISSN: 0921-4534	
/BT/	A4	COTELL C.M. ET AL.: "Microstructural Development Of Thin Films Grown By Pulsed Laser Deposition" MATERIALS SCIENCE AND ENGINEERING B, ELSEVIER SEQUOIA, LAUSANNE, CH, vol. 32, no. 3, July 1, 1995 (1995-07-01), pages 221-230, XP002297626, ISSN: 0921-5107	
/BT/	A5	FLTYN S.R. ET AL.: "Pulsed Laser Deposition Of Thick YBa ₂ Cu ₃ O ₇ -Films With J _c >1 MA/cm ² " APPLIED PHYSICS LETTERS, AIP, AMERICAN, vol. 63, no. 13, September 27, 1993 (1993-09-27), pages 1848-1850, XP000397802, ISSN: 0003-6951	

Examiner
Signature

/Brian Talbot/

Date
Considered

02/12/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 801.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.87 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.